

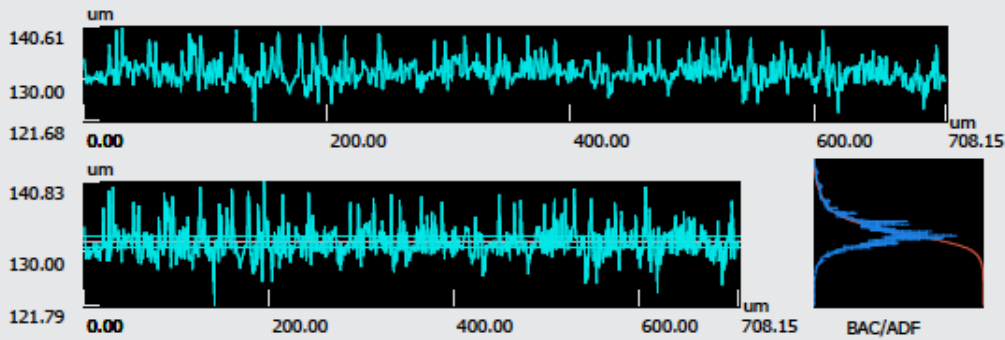
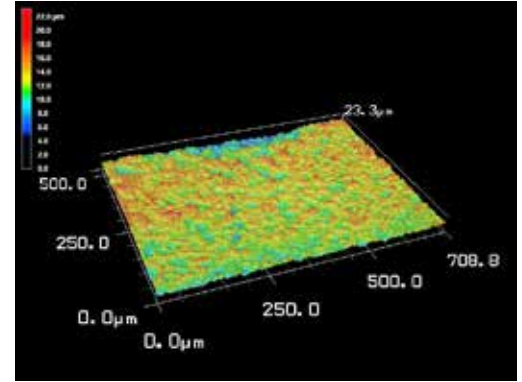
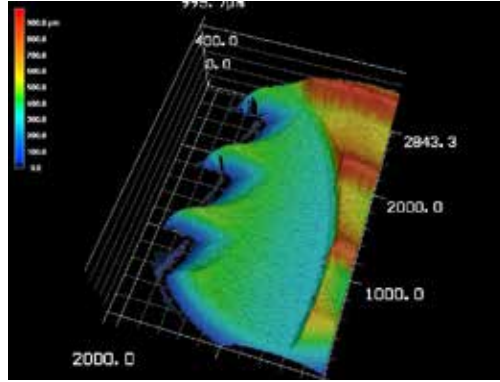


TECHNISCHE  
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## YÜZEY PÜRÜZLÜLÜK ANALİZ RAPORU

### SURFACE ROUGHNESS TEST REPORT

Viyana Teknik Üniversitesi laboratuvarlarında gerçekleştirilen test kapsamında, 3D optik yüzey profilometresi ve sivri uçlu profilometre kullanılarak pürüzlendirme sonrası yüzey topografisi incelenerek homojen bir yüzey yapısı olduğu sonucuna varılmıştır.



Profile	SSc	Smr	Smrln	SDc	SDSc	Sk	Skp	Skln	SA1	Sk	Skp2	SA2	Comment
All	2.41um	30.00%	0.00%	1.07pieces	1.57pieces	4.36um	3.69um	15.69%	28.62um%	1.97um	92.09%	7.78um%	
Parameter1	Ref. nr=25.00%	Ref. nr=30.00%	Cut level=0.00um	D.Z. width=5.00%	Cut level=50.00%								
Parameter2	Comp. nr=75.00%	Lt. dB=0.00um											

Profile1	Rt	Rz	Ra	Rq
All	19.04um	16.79um	1.77um	2.40um

Profile1

Line type : Horz.

Ave: None

Correction : Smooth intensity None, DCL/BCL None, Smooth height None, Correct tilt None

JIS B0601:2001(ISO 4287:1997)

Cutoff : Roughness λs None, λc 0.25mm

Stylus mode : OFF

Line roughness MeasureData20140117191337.vk4 1/17/2014 7:14:32 PM